L Number	Hits	Search Text	DB	Time stamp
1	4	6491518.pn.	USPAT;	2003/03/10 09:49
		•	US-PGPUB:	
			EPO, JPO,	ľ
			DERWENT;	
			IBM TDB	
8	8	"silicon jig"	USPĀT;	2003/03/10 09:50
		, ,	US-PGPUB;	2003/ 03/ 10 0/.50
			EPO; IPO;	
			DERWENT:	
			IBM TDB	
15	215	"glass jig" or "semiconductor jig"	USPĀT;	2003/03/10 10:16
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	US-PGPUB;	2003/ 03/ 10 10:10
			EPO; IPO;	
			DERWENT;	
			IBM TDB	
22	214	("glass jig" or "semiconductor jig") not "silicon jig"	USPAT;	2003/03/10 09:53
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	US-PGPUB;	2003/03/1007.33
			EPO; JPO;	
			DERWENT;	
			IBM TDB	1
29	90	(("glass jig" or "semiconductor jig") not "silicon jig") and (wafer or substrate)	USPĀT;	2003/03/10 09:53
		("and or substance)	US-PGPUB;	2003/03/1007.33
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
36	1	"si jig"	USPAT;	2003/03/10 10:15
		, · · ·	US-PGPUB;	2003/03/10 10:13
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
43	2889	((glass or semiconductor) with jig) not ((("glass jig" or "semiconductor jig") not	USPĀT;	2003/03/10 10:19
		"silicon jig") and (wafer or substrate)) and (wafer or substrate)	US-PGPUB;	2003/ 03/ 10 10:17
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	EPO; JPO;	
			DERWENT;	
			IBM TDB	
50	301	((glass or semiconductor) near1 jig) not ((("glass jig" or "semiconductor jig") not	USPĀT;	2003/03/10 10:19
		"silicon jig") and (wafer or substrate)) and (wafer or substrate)	US-PGPUB;	2003/ 03/ 10 10.17
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	EPO; JPO;	
			DERWENT;	
			IBM TDB	
57	5	((glass or semiconductor) near1 (jig and made)) not ((("glass jig" or	USPĀT;	2003/03/10 10:20
		"semiconductor jig") not "silicon jig") and (wafer or substrate)) and (wafer or	US-PGPUB;	2003/ 03/ 10 10:20
		substrate)	EPO; JPO;	
			DERWENT:	
			IBM TDB	
64	808	((glass or semiconductor) with (jig and made)) not ((("glass jig" or	USPĀT;	2003/03/10 10:21
		"semiconductor jig") not "silicon jig") and (wafer or substrate)) and (wafer or	US-PGPUB;	
	- 1	substrate)	EPO; JPO;	
	!		DERWENT;	
			IBM TDB	
71	513	((glass or semiconductor) with (jig and made and material)) not ((("glass jig" or	USPĀT;	2003/03/10 10:22
		"semiconductor jig") not "silicon jig") and (wafer or substrate)) and (wafer or	US-PGPUB;	2005/ 05/ 10 10:22
		substrate)	EPO; JPO;	
		·	DERWENT;	
			IBM TDB	
78	81	((glass or semiconductor) with (jig and made and material and contaminat\$3)) not	USPĀT;	2003/03/10 10:23
	1	((("glass jig" or "semiconductor jig") not "silicon jig") and (wafer or substrate))	US-PGPUB;	2003, 03, 10 10:23
		and (water or substrate)	EPO; JPO;	
			DERWENT;	